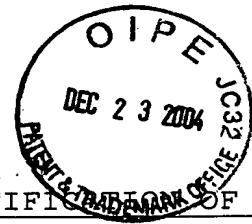


P2001,0128



CERTIFICATE OF MAILING OR TRANSMISSION

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Signature

December 20, 2004  
Date

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No. : 10/635,583 Confirmation No. 8569  
Applicant : Heiko Hommen, et al.  
Filed : August 6, 2003  
Title : Method for Exposing at Least One or at Least  
Two Semiconductors Wafers  
Group Art Unit : 1756  
Examiner : Christopher G. Young  
  
Docket No. : P2001,0128  
Customer No. : 24131

A M E N D M E N T

Mail Stop Amendment  
Hon. Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir :

Responsive to the Office Action dated February 9, 2004, kindly  
amend the above-identified application as follows:

**Amendments to the Claims** begin on page 2 of this paper.

**Remarks/Arguments** begin on page 10 of this paper.